EBARA IR Day 2021

<Session 1>



Precision Machinery Company - Medium-to Long-term Direction

July 8, 2021

Tetsuji Togawa Executive Officer President of Precision Machinery Company

Looking ahead, going beyond expectations

Ahead Beyond

株式会社 荏原製作所

Long-term vision, "E-Vision2030"



Precision Machinery Business: Contribution to Achieve Our 10 Year Vision from Now

In Feb 2020, established a Long-term Vision: E-Vision 2030

10-Year vision to solve material issues integrating a global market-in approach

5 Material Issues (Materiality)



1.Contribute to the creation of a sustainable society



2.Elevate standards of living and support abundant lifestyles for all



3.Conduct comprehensive environmental management



4.Promote working environments that encourage challenge



5.Enhance corporate governance

Outcomes



10-Year Vision

Social/Environmental Value

Solve social issues through our business:

- Reduce GHG emissions equivalent to around 100 million tons of CO2
- Deliver water to 600 million people
- Contribute to development of ICAC5...Challenge 14Å

Economic Value

- **ROIC** over 10.0%
- · Roughly 1 trillion yen in sales

(Indicator of Corporate Value)

 1 trillion yen in market capitalization

Medium-term management plan, "E-Plan2022" Precision Machinery Business Initiatives



Growth Strategy of Precision Machinery Business

Basic Policies

- Expand market share in existing markets by transitioning from a supplier of standalone equipment to a solutions provider
- Promote production efficiency, including increasing automated plants, and strengthen global supply chain

Operating Income Target

2020 Actual 8.1%



2022 Target 13.0% or higher

Major future initiatives

- Install new assembly line at the Kumamoto Plant
- Promote production of major components at overseas bases
- Increase share of Chinese market by strengthening sales capabilities
- Complete construction and start operation of dry vacuum pump overhaul base in China
- Construct an new equipment building at Fujisawa Plant

: Increase market share

: Improve profitability



Image of completed overhaul base



CMP Technology Trends and Production System

July 8, 2021

Seiji Katsuoka Executive Officer and Division Executive Equipment Division, Precision Machinery Company

Looking ahead, going beyond expectations

Ahead > Beyond

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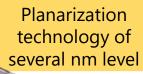


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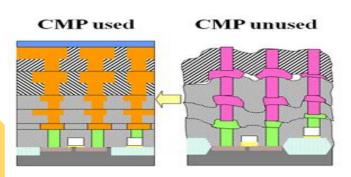
1. What is CMP?





Ultra-high-precision sensor and film-thickness

monitoring technology



CMP (Chemical Mechanical Polisher) Systems

- ✓ Equipment for planarizing patterns on silicon wafers during semiconductor device manufacturing
- ✓ Integration of wafer polishing to achieve planarization at the level of several nm, process control technology and fine-particle cleaning technology at the level of several tens of nm
- ✓ Competitive edge built with abundant knowhow and patents based on nearly 30 years of CMP experience

Polishing

Table D

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Table B

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Cleaning and Drying

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Cleaning technology at several 10nm level

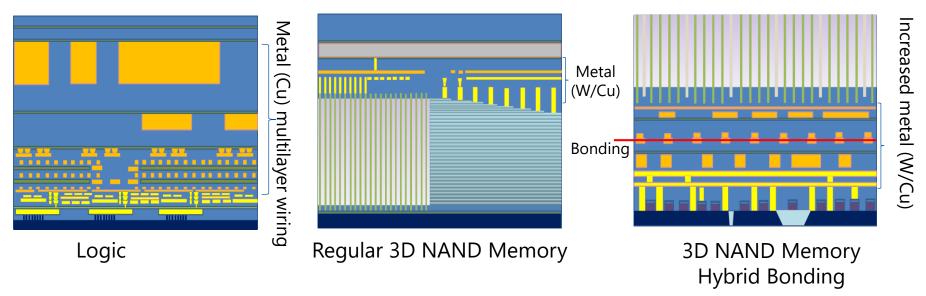
Non-contact cleaning technology

Water-mark-free drying technology

EBARA

2. CMP Process by Device and Adoption of Ebara Products

Image of Layer Structures



- ✓ Logic: High share in metal CMP. Cu (copper) wiring requires CMP process for 10 or more layers.
- ✓ Memory: High share in metal CMP. Non-metal CMP processes evaluations and orders started to increase.
- ✓ New CMP process: CMP processes used before and after bonding with hybrid bonding structure. More metal CMP processes used due to structural changes.

3. Semiconductor Technology Trends and CMP



■ Image of CMP Business Growth toward 2030

External Environment

- Growing semiconductor demand
- ✓ Expanding CMP market



EBARA's Strengths

- High market share in metal CMP processes
- Equipment providing high productivity
- Agile customer support



- Capture market growth
- Increase market share

■ Global demand for semiconductors is increasing significantly in a wide range of fields due to the progress of ICAC5.













CIS/MEMS sensors



Cloud data servers







EV and AV

5G mobile communication

Source of images: https://www.photo-ac.com/

■ CMP will play even more important role in semiconductor manufacturing in the future

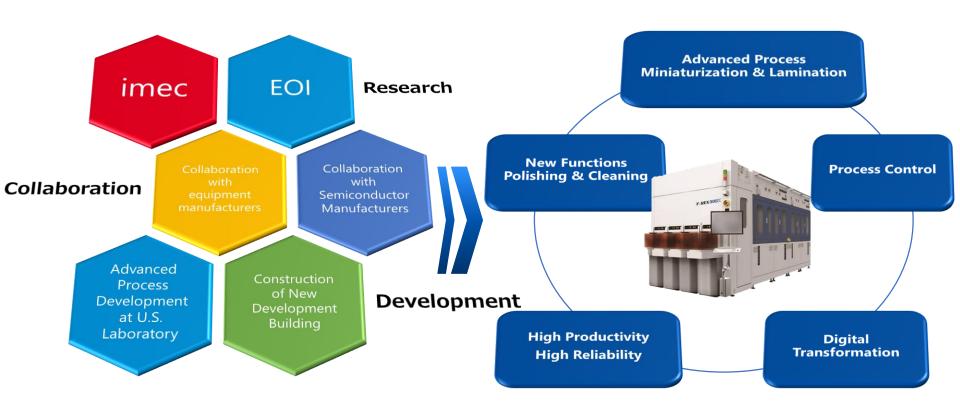
✓ Demand for CMP is expected to increase due to increase of product markets requiring semiconductors, and increase in the types of semiconductors.

Al Semiconductors

- ✓ The number of CMP processes is expected to increase due to further layer increase as a result of advanced technology nodes and changes in semiconductor structures to improve semiconductors performance.
- ⇒ CMP market is expected to grow to be 1.5 times in 2030 (EBARA survey, vs. 2020)



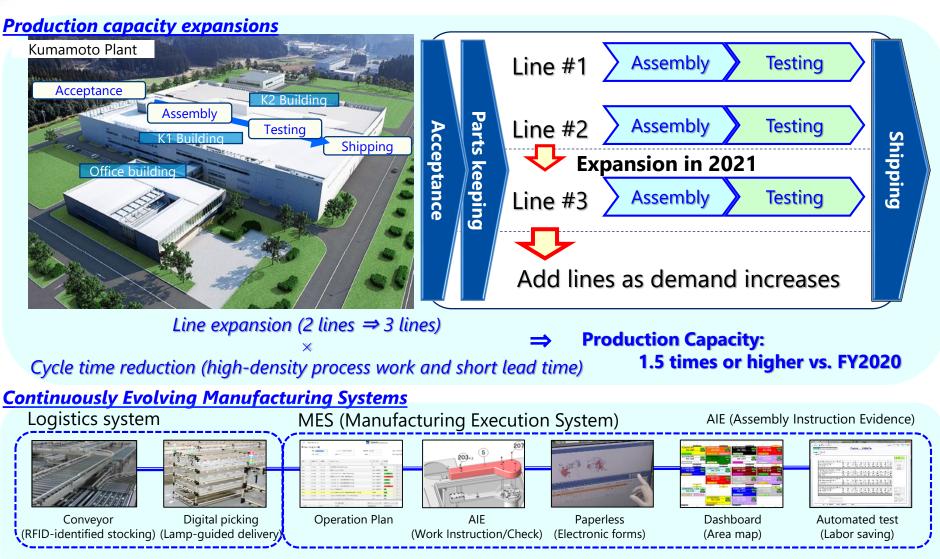
4. CMP Development Trends



EOI: EBARA Open Innovation, a joint research framework with universities imec: An international research Institution

5. Production System and Manufacturing IT System







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